



Article Surface and Electrical Characterization of Bilayers Based on BiFeO₃ and VO₂

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Abstract: Thin films of BiFeO₃, VO₂, and BiFeO₃/VO₂ were grown on SrTiO₃(100) and Al₂O₃(0001) monocrystalline substrates using radio frequency and direct current sputtering techniques. To observe the effect of the coupling between these materials, the surface of the films was characterized by profilometry, atomic force microscopy, and X-ray photoelectron spectroscopy. The heterostructures, monolayers, and bilayers based on BiFeO₃ and VO₂ grew with good adhesion and without delamination or signs of incompatibility between the layers. A good granular arrangement and RMS roughness between 1 and 5 nm for the individual layers (VO₂ and BiFeO₃) and between 6 and 18 nm for the bilayers (BiFeO₃/VO₂) were observed. Their grain size is between 20 nm and 26 nm for the individual layers and between 63 nm and 67 nm for the bilayers. X-ray photoelectron spectroscopy measurements show a higher proportion of V⁴⁺, Bi³⁺, and Fe³⁺ in the films obtained. The homogeneous ordering, low roughness, and oxidation states on the obtained surface show a good coupling in these films. The I-V curves show ohmic behavior at room temperature and change with increasing temperature. The effect of coupling these materials in a thin film shows the appearance of hysteresis cycles, I-V and R-T, which is typical of materials with high potential in applications, such as resistive memories and solar cells.

Keywords: thin films; BiFeO₃/VO₂; solid-solid interface; surface characterization; electrical property

1. Introduction

Bismuth ferrite (BiFeO₃ (BFO)) is a multiferroic material exhibiting the coexistence of ferroelectricity (FE) and antiferromagnetism (AF) at room temperature [1–5]. In thin film form, the FE and AF order parameters of multiferroics could be affected for the phenomenon of magnetostriction [1–4] due to the change in the dimensions of the material as a consequence of stresses generated at the contact interface, either with the substrate or with another material.

Studies of the phenomena that lead to the improvement of magnetostriction and/or ferroelasticity properties focus mainly on changes in the crystalline structure of a material by the incorporation or substitution of other elements [6–8]. However, another alternative is the coupling of different materials in thin film heterostructures (see [9–11]). Therefore, studying the coupling of the BFO with a material that can generate stress in its crystalline lattice with a structural phase transition is shown as a promising path. Here, the intrinsic capacity of these structures to host the ions of a different chemical nature and size, as well as the coupling of their properties through a contact interface, allows the refining of the physicochemical properties of these compounds in a wide range of possibilities.



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Copyright: © 2022 by the authors. Licensee MDPI, Basel, Switzerland. This article is an open access article distributed under the terms and conditions of the Creative Commons Attribution (CC BY) license (https:// creativecommons.org/licenses/by/ 4.0/). To study this mechanism of coupling at the interface with BFO, the vanadium dioxide (VO_2) system was used, which has been widely analyzed due to the structural change it undergoes from VO₂ (monoclinic) to VO₂ (tetragonal) at a temperature of 340 K, showing weak ferromagnetic behavior [12,13]. The combination of these materials in heterostructures gives access to the study of mixed properties and their control.

As far as we can determine, there are currently no reports in the literature that show the growth of BFO thin films over VO2. This is mainly due to the incompatibility between the crystalline structures analyzed. However, there are reports on the growth of bilayers with similar crystalline structures or lattice parameters close to those of BFO and VO₂ that presented good coupling, compatibility, and interesting physical properties, such as the TiO_2 and de BaTiO_3. Good compatibility might, therefore, be expected in the bilayer system based on BFO and VO2 since the interface effects are predominant and detectable in analogous materials [14]. De la Venta et al. [12,13,15,16] showed the change in the coercivity of thin films of nickel deposited on V_2O_3 and VO_2 , a change attributed to the structural phase transition of V₂O₃ and VO₂. Saerbeck et al. [17] studied and compiled information about the coupling between magnetism and the structural phase transition by interfacial tension in different systems of $La_{0.7}A_{0.3}MnO_3$ (A = Sr,Ca), Fe₃O₄, CoFe₂O₄, FeRh, Ni, Fe, and Co, using, as a base, the structural change in the VO_2 , V_2O_3 , and $BaTiO_3$ compounds, resulting in structures with hybrid properties that manage to modify and/or control the magnetic behavior through the effects of tension and inverse magnetostriction. A recent study [18] reports the progress in BFO-based superlattices, which the physical properties of these multifunctional materials have not been explored enough.

On the other hand, Lee et al. [19] reported that $BaTiO_3$ presents a perovskite-type crystalline structure like that of BiFeO₃ with magnetostriction effects. They reported on the modification of the tension of SrRuO₃ and La_{0.67}Sr_{0.33}MnO₃ films induced by the phase transition of the BaTiO₃ substrate, observing the effects of biaxial stress induced on the electric and magnetic transport of these compounds.

Furthermore, Burbure et al. [20] studied the orientation and phase relationship between TiO₂ films and BaTiO₃ substrates; considering that TiO₂ has the structure and lattice parameters of VO₂, they determined that despite having a high mismatch index, bilayers that present good coupling and epitaxy were grown in different crystalline planes. Feng [21] and Sarkar et al. [22] worked on the development of multifunctional nano-heterostructures of BiFeO₃/TiO₂, analyzing photo-ferroelectricity, transport, and non-volatile switching resistances. Zhang et al. [23] used combinatorial substrate epitaxy (CSE) in 150 samples to determine the phase and orientation relationships in the BiFeO₃/TiO₂ bilayers. They also proposed the configuration scheme structure whereby the coupling between the layers of these materials with mismatches is presented. However, it was shown that the structural coupling of both the anatase phase of TiO₂ (like VO₂ (M)) and the rutile phase (like VO₂ (R)) is ordered.

In this article, we present a new $BFO/VO_2/Al_2O_3$ heterostructure with very interesting and promising properties. Also, an analysis of the surface, growth rate, roughness, and grain size were carried out. In addition, an electrical study was carried out where notable changes in the electrical properties of the bilayers were shown when subjected to different temperatures.

2. Experimental Details

Thin films of BFO, VO₂, and BFO/VO₂ were grown on SrTiO₃(100) and Al₂O₃(0001) substrates using RF and DC sputtering under internal pressure of 4.5×10^{-4} mbar and atmospheres of argon and oxygen. All materials, targets (BFO and metallic vanadium, V, with a purity of \geq 99.99%), and substrates were obtained from Plasmaterials, Inc. The VO₂ films were grown in an O₂-atmosphere at a pressure of 1.72 mbar, power of 53 W, and substrate temperature of 450 °C. In turn, the top BFO layer was deposited in an argon atmosphere (2 × 10⁻¹ mbar) at a power of 100 W and a substrate temperature of 550 °C. After deposition, both the single VO₂ films and the heterostructures were annealed in-situ

for 20 min in 20% of O₂ and 80% of Ar-mixed atmosphere ($p = 2.4 \times 10^{-1}$ mbar) at the same growth temperature of 550 °C. Monolayers of BFO and VO₂ with "steps" were obtained, covering a section of the substrate with an alumina mask, allowing the deposition of the material only in one region of the substrate.

Contact profilometry measurements were performed using KLA Tencor D-120 equipment with a measuring range from 1 nm to 100 μ m to determine the thickness of the thin films and their growth rate. The surface morphology of the films was examined with an atomic force microscope (AFM, Omicron SPM1), and the Gwyddion software was used to determine the statistical parameters of roughness. The images were processed with an adjusted linear plane to eliminate the inclination before the statistical analysis. The average grain diameter was obtained using ImageJ software. This software was used to delineate the perimeter of the grain, assuming a circular surface. The chemical composition was studied by X-ray photoelectron spectroscopy (XPS) using PHI 1257 spectrometer (PerkinElmer) equipped with a hemispheric electron energy analyzer and an X-ray source with Al K α radiation (h γ = 1486.6 eV). The XPS spectra were adjusted using the Multipack and XP-Speak programs. The energy scale was calibrated by assigning 284.8 eV to the C1s peak corresponding to adventitious carbon. Electrical characterization with resistance curves as a function of temperature R(T) was carried out to study the metal-insulator transition behavior of the VO₂ compound and of the BFO/VO₂ system; additional measurements of the current versus the voltage, I–V, were made by the method of Van der Paw or the method of the four points, and finally, the results obtained were correlated.

3. Results and Discussion

3.1. Profilometry and AFM Studies

Figures 1 and 2 show the profilometry measurements of the VO₂/Al₂O₃ thin films. In Figure 1, the approximate thickness of 77.5 nm provided by the step height parameter (StpHt) indicates a growth rate of 1.3 nm per minute. Instead, in the 3D profile, the uniform height regions can be seen moving away from the step, denoting an ordered growth. In the case of the BFO/SrTiO₃ thin films (see Figures 3 and 4), the thickness of the BFO films was 106.5 nm, on average, which indicates a growth rate of 2.4 nm per minute under the BFO growth parameters. In these films, the step is more marked, possibly because the mask was much better adhered to and did not allow diffusion between the film and mask. Although the maximum height, *Z*, is lower than in the VO₂ films, there is less homogeneity, and there are several zones with different heights.

Surface roughness plays an important role in the effects generated at the interface of the films. For example, in multiferroics systems, the roughness can influence the magnetic and electrical properties of these films. Therefore, the surface of the individual layers and the BFO/VO₂ heterostructures were analyzed by AFM (see Figures 5–7) [24]. Good granular ordering and the RMS roughnesses between 1 and 5 nm were observed for the individual layers and between 6 and 18 nm for the bilayers (see Figure 8). The films exhibited a dense morphology, a continuous surface, and a fine grain microstructure without cracks. The samples with a greater presence of high peaks are due to the agglomerations of the particles that appear in longer growth times, in the same way the grain size for long growth times is smaller and with more uniformity.

Figure 5 shows the image of the surface scan of a section of $1 \times 1 \ \mu m^2$ and a histogram with the average grain size, which was 26 nm for a monolayer film of VO₂. In these monolayers, the surface roughness and grain size increase with the deposition time. However, Figure 6 reveals that the grain size of the BFO films is highly homogeneous. No large peaks or valleys were observed. The average grain size is 20 nm, and the roughness does not seem to increase significantly with the increase in thickness.



Figure 1. (a,b) Profilometry measurements at two different points of thin films of VO₂ on Al₂O₃.



Figure 2. 3D image obtained by profilometry of the surface of thin films of VO_2 on Al_2O_3 .



Figure 3. (a,b) Profilometry measurements at two different points of thin films of BFO on SrTiO₃.



Figure 4. 3D image obtained by profilometry of the surface of thin films of BFO on SrTiO₃.



Figure 5. AFM measurements and average grain size for VO₂ thin films.



RMS roughness 0.569 nm

Figure 6. AFM measurements and average grain size for BFO thin films.



Figure 7. AFM measurements and average grain size for BFO/VO₂ thin films with BFO layers of (**a**) 30 nm and (**b**) 60 nm.



Figure 8. Roughness of films based on BFO and VO₂.

Figure 7 shows that the grain size of the BFO/VO₂ films is 63 nm and increases to 67 nm when the BFO layer is 30 and 60 nm, respectively. This could be because the grain geometry is more elongated in the bilayers of 30 nm and roughness of 10.10 nm than with a bilayer of 60 nm and roughness of 16.62 nm. This shows us a more elongated grain geometry in the bilayers, especially the bilayers with greater thicknesses. This elongation in the grains influences the roughness, which increases with respect to the individual layers; this translates into greater growth by the islands and agglomerations of scattered particles with greater height.

Thus, the literature reports that these films grow layer by layer following the structure of the terraces and substrate steps [25–29]. The atoms reaching the surface of the substrate are placed in the middle of the step, and, from there, the structure grows in a 2D form until there is a complete coalescence between the different levels of the layers. The atoms deposited on the substrate are more strongly attached to the next layer and so on. Growth with a larger and not-so-homogeneous grain size can be seen for the top layer of BFO/VO₂/Al₂O₃ with respect to the individual layers [25]. A degree of organization and the absence of cracks are observed, indicating good diffusion and coupling between the BFO, VO₂, and substrate layers. These characteristics seen in the films contribute to the creation of additional stress that increases with thickness, favoring the formation of islands in the next layer to be deposited. This stress can determine a shift in the critical transition temperature of VO₂ and, therefore, in the bilayer [26–28].

Figure 8 presents a summary of the roughness of the grown films. A semi-exponential upward trend can be observed, showing us how the roughness increases in these films as the thickness and number of layers of these two thin-film materials increase.

3.2. Chemical States

The chemical studies were carried out through XPS analysis to detect the chemical elements present on the surface of these films. The analysis of the surfaces by XPS is a very valuable resource when determining both quantitatively and qualitatively the composition and chemical state of the surfaces. However, the analysis by this technique of first-row transition metals and their oxides and hydroxyls is a challenge due to the complexity of their 2*p* spectra, resulting from asymmetric peaks, the complex division of multiplets, and the uncertain and overlapping union of energies [30].

The XPS measurements are presented for four samples, two monolayers $(VO_2/Al_2O_3$ and BFO/SrTiO_3), and two bilayers $(BFO/VO_2/Al_2O_3, with BFO layers of 30 and 60 nm)$, respectively. These measurements were made in a broad spectrum, and the narrow scans are shown in Figures 9–12. All spectra were adjusted with mixed Lorentzian and Gaussian curves. The Mo signal is from the sample holder.

Figure 9 shows the spectra of the VO_2/Al_2O_3 monolayer in the blue color. In Figure 9a, the absence of impurity peaks, except for molybdenum (Mo) coming from the sample holder used, can be seen. However, in the narrow scan spectrum (Figure 9b), the respective curve adjustment was obtained for the V⁺⁴ peaks (516.6 eV and 524.24 eV), V⁺⁵ peaks (517.94 eV and 525.58 eV), O_L peak (530.84 eV), and O_H peak (532.81 eV), respectively. Here, the O_L and O_H peaks correspond to the bonds of oxygen with hydrogen and with the crystal lattice of the compound studied and indicate that the films are very susceptible to oxidation in the environment. In addition, a spin-orbit splitting of 7.64 eV typical of vanadium oxides was observed, and it is evident that the predominant oxidation state is V^{+4} , which corresponds to VO_2 . On the other hand, Figure 9a shows the spectra of the BFO/SrTiO₃ monolayer in the green color. Signals from bismuth, iron, oxygen, and molybdenum (from the sample holder) were observed. However, using a narrow scan is possible to determine the composition of the thin film (Figures 10a and 11a). Signals from Fe(2*p*) doublet (at 710.02 and 723.62 eV) and Bi(4*f*) doublet (at 156.84 and 162.15 eV), including metallic Bi, were observed. The binding energies' differences for each are 13.6 eV and 5.31 eV, respectively, which constitutes a response of iron oxides and bismuth oxides. On the other hand, the high-resolution spectra of oxygen (O1s, see Figure 12a) show the presence of the oxides of the lattice (metallic oxides, O_L) and hydroxyl oxygen (O_H) in the thin films. Therefore, it is clearly observed that the predominant oxidation states are Fe^{3+} and Bi^{3+} , corresponding to the structure of $BiFeO_3$.

For the bilayer thin films, see Figure 9a in the red and black colors; a BFO of 30 nm can be seen in Figures 10, 11 and 12b, and a BFO of 60 nm can be seen in Figures 10, 11 and 12c. We can observe that the Fe(2p) doublet and Bi(4f) doublet's binding energies difference of 13.6 eV and 5.31 eV are maintained. Therefore, the BFO thin films with a layer of 30 nm exhibit more oxidation states, as well as a shift towards higher binding energies. However, an ion bombardment revealed that the amount of Fe³⁺ increases in the BFO thin films, unlike the surface where there was a higher presence of the Fe^{2+} oxidation state. In the bilayers, there was a small displacement of the maximums towards higher values of binding energy; however, this did not increase the number of oxidation states, and it can be noted that at lesser layers, Fe^{3+} increases in proportion. On the other hand, it is evident that Bi^{3+} is very predominant in both the monolayers and bilayers. Instead, there is an increase in the contribution of the oxides of the lattice (metallic oxides, O_L) for the bilayers, which is a good indication that the surface area is more homogeneous and that there is less contamination. In addition, hydroxyl oxygen (O_H) increases in the thin films with a lower growth power and in the eroded sample, which may suggest that these thin films could be more photocatalytic.



Figure 9. (a) The survey scans of the XPS spectra for the monolayers (BFO and VO₂) and bilayers (BFO/VO₂/Al₂O₃ with BFO 30 nm and 60 nm) (b) narrow scan XPS spectrum of VO₂ monolayer.



Figure 10. (**a**) XPS narrow scan of Fe 2p signals for (**a**) BFO/SrTiO₃, (**b**) BFO/VO₂/Al₂O₃ with a BFO of 30 nm, and (**c**) BFO/VO₂/Al₂O₃ with a BFO of 60 nm.



Figure 11. (a) An XPS narrow scan of Bi 4f signals for (a) $BFO/SrTiO_3$, (b) $BFO/VO_2/Al_2O_3$ with a BFO of 30 nm, and (c) $BFO/VO_2/Al_2O_3$ with a BFO of 60 nm.



Figure 12. An XPS narrow scan of O 1s signals for (**a**) BFO/SrTiO₃, (**b**) BFO/VO₂/Al₂O₃ with a BFO of 30 nm, and (**c**) BFO/VO₂/Al₂O₃ with a BFO of 60 nm.

Figure 13 and Table 1 show a summary of the atomic percentages of the thin films analyzed in this work. It is observed that the VO₂ films most indicated to be coupled with the BFO films are those with 60 min of growth since they have a higher percentage of vanadium on the surface and present a higher proportion of V⁴⁺. On the other hand, the most suitable BFO films to couple in the bilayer with VO₂ are those with a BFO layer of 30 nm because they show iron with a higher atomic percentage in the surface area and a higher Fe³⁺ ratio.



Figure 13. Atomic percentages on the surface of the selected films.

Table 1. Summary of atomic percentages on the surface of the thin films obtained.

Films	Atomic% Fe	Atomic% O	Atomic% Bi	Atomic% C	Atomic% V
BFO 60 nm	5.28	73.46	21.26	59.49	_
VO ₂ 80 nm	-	84.91	-	79.66	89.61
BFO-VO ₂ 30 nm	3.25	75.98	20.77	52.24	-
BFO-VO ₂ 60 nm	1.92	72.64	25.44	42.26	-

Finally, it should be noted that growing this type of film in a bilayer without previous antecedents constituted a challenge, not only because of the coupling of their crystalline structures before and after the VO₂ transition temperature but also because the upper layer (BFO) is grown at a higher temperature than the lower VO₂ layer and even its annealing temperature at 470 °C. This has, therefore, a deoxidation effect on the VO₂ film, turning it metallic and losing its metal-insulator transitions (MIT), which is not desirable, since coupling with a material that presents a structural phase transition is essential to generate a new line of applications and studies of the physical properties of these bilayers. Therefore, the VO₂ films were carefully over-oxidized, anticipating these losses when the upper BFO film grew, and in this way, a growth methodology of these bilayers was obtained.

3.3. Electrical Characterization

One of the best indications of good coupling in the bilayers based on BFO and VO₂ is that these also present hysteresis curves with a decrease of several orders of magnitude of electrical resistance in a fairly short time (see Figure 14 left); even so, there is a leftward shift in the transition temperature with respect to the 340 K of VO₂. This lower value (around ~325 K) can be caused by an increase in the interfacial tension in VO₂ since there are studies, such as those reported in [26,31], which show us that there is a relationship

between the increase in the tension of the crystal lattice in VO_2 and the decrease in critical temperature. This result corroborates the XRD analysis that shows tensions in its crystal lattice; this would be not only with the substrate of Al_2O_3 but also with the film on it (BFO). Additionally, this possibly contributes to an increase of the voltage of the lattice in the VO_2 and, therefore, to decrease the transition temperature.



Figure 14. (left) Resistance curves as a function of temperature for VO_2/Al_2O_3 (VO_2 80 nm), BFO/ VO_2/Al_2O_3 (BFO layer of 30 nm) and BFO/ VO_2/Al_2O_3 (BFO layer of 60 nm) (right) derived from electrical resistance as a function of temperature for the films obtained.

The electrical properties of the BFO/VO₂/Al₂O₃ heterostructures are shown in Figure 14. A well-defined MIT with a resistance change of two and three orders of magnitude (ΔR ~100 and ~1000) can be seen in (a) and (b) with a T_{MIT} between ~322 and 327 K (hysteresis width between $\Delta H \approx 4$ and 3 K) for the 30 and 60 nm bilayers, respectively. T_{MIT} is estimated by the well-known expression T_{MIT} = 1/2(T_c - T_h). Here, (T_c - T_h) represents the transition temperatures at the center of the derived curve (d[log(R)]/dT) during the cooling and heating procedure, respectively (inset in Figure 14 on the right). The observation of an MIT, which improves the conductivity of the studied system, confirms the presence of the VO₂(M) phase in the lower film. Here, it should be noted that the VO₂(B) phase exhibits neither MIT nor thermal hysteresis phenomena [32]. The resistance of VO₂(B) decreases exponentially with increasing temperature [33]. It is striking that the measured T_{MIT} of the polycrystalline film VO₂ in the heterostructure is relatively low compared to that reported for individual crystals or epitaxial thin films [34]. This finding, along with the observed resistance change of several orders of magnitude, is in agreement with the results reported for polycrystalline VO₂ thin films [35,36].

From Figure 14, we can conclude that the thermal stability of the coupled material strongly depends on the transition temperatures observed for each bilayer; however, by having reproducibility, we can see the heterostructure as a single coupled material with an operating range between 300 K and 380 K; within this range, a very interesting behavior is observed that could give rise to the study and/or application of the control of electrical, ferroelectric, or magnetic properties.

It is worth mentioning that the growth of polycrystalline thin films of VO₂ with reduced T_{MIT} is technologically interesting and constitutes a current research topic in solid state physics [37]. Although the T_{MIT} of the polycrystalline thin film VO₂ can be effectively adjusted and various approaches have been adopted to explain the origin of the reduced T_{MIT} , there is no consensus on this matter. Therefore, the true physical mechanism behind the reduction in the T_{MIT} value of polycrystalline VO₂ thin films remains an open question.

Although understanding the phase transition in thin-film VO_2 is challenging, it is probably related to a network distortion process. In a simplified image, it has been argued that a charge density wave along the c-axis of rutile [38], with the wave vector 2cR, forms during the transition. As a result, the unit cell along the c-axis is duplicated, generating a periodic distortion of the network in this direction. A slight rotation of the dimers with respect to the c-axis has also been verified [38]. As for the phase transition of VO₂ polycrystalline films, it is evident that the phase transition, in this case, is easier than that of VO₂ monocrystals [27]. The main feature of VO₂ polycrystalline films is the deformation compatibility between differently oriented grains. Therefore, it is to be expected that the grains oriented along specific directions may have irregular distortions of the network.

To finish with the characterizations carried out, it was decided to study I-V curves to analyze the electrical behavior of the bilayer thin film with a BFO layer of 30 nm as a first approximation to future studies of these bilayers in functional applications for storage devices, such as memresistors. The bilayer thin film with a BFO layer of 30 nm was chosen because it was the one that, in percentage, varied its electrical and magnetic responses more compared to the MIT of VO₂ and, therefore, the film that has the greatest potential to work with nanotechnological applications or prototypes.

Figure 15 shows the I–V curves of BFO/Al₂O₃ (a BFO layer of 30 nm) with varying voltage from 0 V to 200 V at different temperatures (Figure 15 (up)) and from -200 V to 200 V at a temperature of 320 K (Figure 15 (down)). Here, it is evident how the film progressively goes from having an ohmic behavior at room temperature to having a hysteresis cycle typical of resistive memories, which has a maximum width of ~20 V and, as the temperature decreases, this hysteresis cycle closes.



Figure 15. I-V curves for a BFO/VO₂/Al₂O₃ bilayer, with a BFO layer of 30 nm with different temperatures (**up**) and at 320 K with positive and negative voltage values (**down**).

Studying more thoroughly the I-V of the bilayer at 320 K, we can observe a difference in the symmetry of the resistive cycle with positive and negative voltages; however, the negative voltage cycle is more closed, an effect that agrees with what is reported in [39,40]. Here, it is denoted that it is typical behavior of these memresistor materials that they change their response with each measurement.

On the other hand, effects such as magnetoelectric coupling and its behavior at different fields and with temperatures before and after the transition would be the next step for the study of these heterostructures with a high mismatch and FE/AF/MIT coupling.

4. Conclusions

It was possible to obtain the growth parameters for films based on BFO and VO₂, together with a methodology that allows obtaining a good coupling between films and the desired oxidation states of vanadium, bismuth, and iron. BFO and VO₂ monolayers were obtained with an ordered growth, good adherence, roughness (between 0.2 and 2.3 nm), and grain size (between 20 and 32 nm). In addition, an ordered growth without cracks is evidenced. AFM measurements show differences in the topography of the individual layers and bilayers, a change in the average grain diameter from 20 nm to 67 nm, and a change in the roughness from 0.2 nm to almost 16 nm in the BFO/VO₂ bilayers.

The AFM measurements show differences in the topography of the individual monolayers and bilayers; a change in the average grain diameter from 20 nm to 67 nm was observed, and a change in roughness from 0.2 nm to nearly 16 nm was observed in the BFO/VO₂ bilayers. In addition, an orderly growth without cracks (AFM) is evident. The homogeneity observed in the films with the best results will possibly contribute to obtaining good results in characterizations of the current, voltage, resistance, and behavior against the electric and magnetic fields. It was observed by means of XPS that the predominant oxidation state in the individual and bilayer thin films is VO₂. However, there is also a presence in the films of the V₂O₅ phase. The BFO and BFO/VO₂/Al₂O₃ films show the presented BiFeO₃ as the predominant phase.

It is pertinent to say that these new heterostructures are an excellent example of how synergistic effects in thin film physics can help drive new studies in already known areas and materials.

Furthermore, thin films show a structural phase change with a resistance change of several orders of magnitude, both for the monolayers and for the bilayers. Also, hysteresis loops are presented here, which is an excellent indication to work these films in memresistor and solar cells.

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References

- Mao, W.; Yao, Q.; Fan, Y.; Wang, Y.; Wang, X.; Pu, Y.; Li, X. Combined experimental and theoretical investigation on modulation of multiferroic properties in BiFeO₃ ceramics induced by Dy and transition metals co-doping. *J. Alloys Compd.* 2019, 784, 117–124. [CrossRef]
- Kumar, M.; Yadav, K.L. Magnetic field induced phase transition in multiferroic BiFe1–xTixO3 ceramics prepared by rapid liquid phase sintering. *Appl. Phys. Lett.* 2007, *91*, 112911. [CrossRef]

- Kadomtseva, A.M.; Popov, Y.F.; Pyatakov, A.P.; Vorob'Ev, G.P.; Zvezdin, A.K.; Viehland, D. Phase transitions in multiferroic BiFeO₃ crystals, thin-layers, and ceramics: Enduring potential for a single phase, room-temperature magnetoelectric 'holy grail'. *Phase Transit.* 2006, 79, 1019–1042. [CrossRef]
- 4. Zavaliche, F.; Yang, S.Y.; Zhao, T.; Chu, Y.H.; Cruz, M.P.; Eom, C.B.; Ramesh, R. Multiferroic BiFeO₃ films: Domain structure and polarization dynamics. *Phase Transit.* **2006**, *79*, 991–1017. [CrossRef]
- 5. Martínez, J.; Dionizio, S.; Gutierrez, N.; Mosquera, E.; Diosa, J.E.; Bolañoz, G.; Moran, O. General aspects of the physical beahavior of polycrystalline BiFeO₃/VO₂ bilayers grown on sapphire substrates. *Appl. Phys. A* 2022, *in Press*.
- Freitas, R.R.Q.; Mota, F.D.B.; Rivelino, R.; de Castilho, C.M.C.; Kakanakova-Georgieva, A.; Gueorguiev, G.K. Spin-orbit-induced gap modification in buckled honeycomb XBi and XBi₃ (X = B, Al, Ga, and In) sheets. *J. Phys. Condens. Matter* 2015, 27, 485306. [CrossRef]
- Chakrabarti, K.; Sarkar, B.; Ashok, V.D.; Chaudhuri, S.S.; De, S. Enhanced magnetic and dielectric behavior in Co doped BiFeO₃ nanoparticles. J. Magn. Magn. Mater. 2015, 381, 271–277. [CrossRef]
- Narváez, C.A.; Raigoza, C.F.V.; Nieva, A.P.G. Modificación de las propiedades estructurales, eléctricas y magnéticas del BiFeO₃ por la incorporación de Ba y Nb. *Química Nova* 2017, 40, 182–191. [CrossRef]
- Bea, H.; Bibes, M.; Herranz, G.; Zhu, X.-H.; Fusil, S.; Bouzehouane, K.; Jacquet, E.; Deranlot, C.; Barthelemy, A. Integration of Multiferroic BiFeO₃ Thin Films into Heterostructures for Spintronics. *IEEE Trans. Magn.* 2008, 44, 1941–1945. [CrossRef]
- Wu, S.M.; Cybart, S.; Yu, P.; Rossell, M.D.; Zhang, J.X.; Ramesh, R.; Dynes, R.C. Reversible electric control of exchange bias in a multiferroic field-effect device. *Nat. Mater.* 2010, *9*, 756–761. [CrossRef]
- Kakanakova-Georgieva, A.; Gueorguiev, G.; Sangiovanni, D.G.; Suwannaharn, N.; Ivanov, I.G.; Cora, I.; Pécz, B.; Nicotra, G.; Giannazzo, F. Nanoscale phenomena ruling deposition and intercalation of AlN at the graphene/SiC interface. *Nanoscale* 2020, 12, 19470–19476. [CrossRef]
- Lauzier, J.P.; Sutton, L.; de la Venta, J. Magnetic irreversibility in VO₂/Ni bilayers. J. Phys. Condens. Matter 2018, 30, 374004. [CrossRef]
- 13. Sutton, L.; Blehm, A.; Lauzier, J.; Malone, K.; Smith, G.; Singh, M.; De La Venta, J. Effects of W Doping in VO₂ on the Magnetic Properties of VO₂/Ni Heterostructures. *J. Supercond. Nov. Magn.* **2020**, *33*, 2493–2499. [CrossRef]
- 14. Spaldin, N.A.; Fiebig, M. The Renaissance of Magnetoelectric Multiferroics. Science 2005, 309, 391–392. [CrossRef]
- 15. De La Venta, J.; Wang, S.; Ramirez, J.G.; Schuller, I.K. Control of magnetism across metal to insulator transitions. *Appl. Phys. Lett.* **2013**, *102*, 122404. [CrossRef]
- 16. de la Venta, J.; Wang, S.; Saerbeck, T.; Ramírez, J.G.; Valmianski, I.; Schuller, I.K. Coercivity enhancement in V₂O₃/Ni bilayers driven by nanoscale phase coexistence. *Appl. Phys. Lett.* **2014**, *104*, 062410. [CrossRef]
- 17. Saerbeck, T.; de la Venta, J.; Wang, S.; Ramirez, J.G.; Erekhinsky, M.; Valmianski, I.; Schuller, I.K. Coupling of magnetism and structural phase transitions by interfacial strain. *J. Mater. Res.* **2014**, *29*, 2353–2365. [CrossRef]
- Yin, L.; Mi, W. Progress in BiFeO₃-based heterostructures: Materials, properties and applications. *Nanoscale* 2020, 12, 477–523. [CrossRef]
- 19. Lee, M.K.; Nath, T.K.; Eom, C.B.; Smoak, M.C.; Tsui, F. Strain modification of epitaxial perovskite oxide thin films using structural transitions of ferroelectric BaTiO₃ substrate. *Appl. Phys. Lett.* **2000**, *77*, 3547–3549. [CrossRef]
- Burbure, N.V.; Salvador, P.A.; Rohrer, G. Orientation and Phase Relationships between Titania Films and Polycrystalline BaTiO₃ Substrates as Determined by Electron Backscatter Diffraction Mapping. J. Am. Ceram. Soc. 2010, 93, 2530–2533. [CrossRef]
- Feng, H.-J. Photovoltaic and magnetic properties of BiFeO₃/TiO₂ heterostructures under epitaxial strain and an electric field. *Mater. Chem. Phys.* 2015, 153, 405–409. [CrossRef]
- 22. Sarkar, A.; Khan, G.G.; Chaudhuri, A.; Das, A.; Mandal, K. Multifunctional BiFeO₃/TiO₂ nano-heterostructure: Photoferroelectricity, rectifying transport, and nonvolatile resistive switching property. *Appl. Phys. Lett.* **2016**, *108*, 033112. [CrossRef]
- Zhang, Y.; Schultz, A.; Li, L.; Chien, H.; Salvador, P.A.; Rohrer, G. Combinatorial substrate epitaxy: A high-throughput method for determining phase and orientation relationships and its application to BiFeO₃/TiO₂ heterostructures. *Acta Mater.* 2012, 60, 6486–6493. [CrossRef]
- 24. Xu, Q.; Sheng, Y.; Xue, X.; Yuan, X.; Wen, Z.; Du, J. Exchange bias in BiFeO₃/La_{0.67}Sr_{0.33}MnO₃ bilayers. *Jpn. J. Appl. Phys.* **2014**, 53, 08NM01. [CrossRef]
- 25. Eckertová, L. Mechanism of Film Formation. In Physics of Thin Films; Springer: Boston, MA, USA, 1977; pp. 72–114. [CrossRef]
- 26. Chen, C.; Zhao, Y.; Pan, X.; Kuryatkov, V.; Bernussi, A.; Holtz, M.; Fan, Z. Influence of defects on structural and electrical properties of VO₂ thin films. *J. Appl. Phys.* **2011**, *110*, 023707. [CrossRef]
- 27. Lin, T.; Wang, L.; Wang, X.; Zhang, Y.; Yu, Y. Influence of lattice distortion on phase transition properties of polycrystalline VO₂ thin film. *Appl. Surf. Sci.* 2016, *379*, 179–185. [CrossRef]
- Cox, P.A. The Electronic Structure of Transition Metal Oxides and Chalcogenides. In *Physics and Chemistry of Low-Dimensional Inorganic Conductors*; Springer: Boston, MA, USA, 1996; pp. 255–270. [CrossRef]
- 29. Oura, K.; Katayama, M.; Zotov, A.V.; Lifshits, V.G.; Saranin, A.A. Growth of Thin Films. In *Advanced Texts in Physics*; Springer: Berlin/Heidelberg, Germany, 2003; pp. 357–387. [CrossRef]
- Biesinger, M.C.; Payne, B.P.; Grosvenor, A.P.; Lau, L.W.M.; Gerson, A.R.; Smart, R.S.C. Resolving surface chemical states in XPS analysis of first row transition metals, oxides and hydroxides: Cr, Mn, Fe, Co and Ni. *Appl. Surf. Sci.* 2011, 257, 2717–2730. [CrossRef]

- Théry, V.; Boulle, A.; Crunteanu, A.; Orlianges, J.C.; Beaumont, A.; Mayet, R.; Mennai, A.; Cosset, F.; Bessaudou, A.; Fabert, M. Role of thermal strain in the metal-insulator and structural phase transition of epitaxial VO₂ films. *Phys. Rev. B* 2016, 93, 184106. [CrossRef]
- 32. Leroux, C.; Nihoul, G.; Van Tendeloo, G. FromVO₂(B) to VO₂(R): Theoretical structures of VO₂ polymorphs and in situelectron microscopy. *Phys. Rev. B* **1998**, *57*, 5111–5121. [CrossRef]
- 33. Ding, Z.; Cui, Y.; Wan, D.; Luo, H.; Gao, Y. High-performance thermal sensitive VO₂(B) thin films prepared by sputtering with TiO₂(A) buffer layer and first-principles calculations study. *RSC Adv.* **2017**, *7*, 29496–29504. [CrossRef]
- Dou, Y.-K.; Li, J.-B.; Cao, M.-S.; Su, D.-Z.; Rehman, F.; Zhang, J.-S.; Jin, H.-B. Oxidizing annealing effects on VO₂ films with different microstructures. *Appl. Surf. Sci.* 2015, 345, 232–237. [CrossRef]
- 35. Brassard, D.; Fourmaux, S.; Jean-Jacques, M.; Kieffer, J.C.; El Khakani, M.A. Grain size effect on the semiconductor-metal phase transition characteristics of magnetron-sputtered VO₂ thin films. *Appl. Phys. Lett.* **2005**, *87*, 051910. [CrossRef]
- Ba, C.; Bah, S.T.; D'Auteuil, M.; Ashrit, P.V.; Vallée, R. Fabrication of High-Quality VO₂ Thin Films by Ion-Assisted Dual ac Magnetron Sputtering. ACS Appl. Mater. Interfaces 2013, 5, 12520–12525. [CrossRef] [PubMed]
- Chen, F.; Fan, L.L.; Chen, S.; Liao, G.M.; Chen, Y.L.; Wu, P.; Song, L.; Zou, C.W.; Wu, Z.Y. Control of the Metal–Insulator Transition in VO₂ Epitaxial Film by Modifying Carrier Density. ACS Appl. Mater. Interfaces 2015, 7, 6875–6881. [CrossRef]
- Morrison, V.R.; Chatelain, R.P.; Tiwari, K.L.; Hendaoui, A.; Bruhács, A.; Chaker, M.; Siwick, B.J. A photoinduced metal-like phase of monoclinic VO₂ revealed by ultrafast electron diffraction. *Science* 2014, 346, 445–448. [CrossRef]
- Hu, Z.; Li, Q.; Li, M.; Wang, Q.; Zhu, Y.; Liu, X.; Zhao, X.; Liu, Y.; Dong, S. Ferroelectric memristor based on Pt/BiFeO₃/Nb-doped SrTiO₃ heterostructure. *Appl. Phys. Lett.* 2013, *102*, 102901. [CrossRef]
- Sun, H.; Luo, Z.; Zhao, L.; Liu, C.; Ma, C.; Lin, Y.; Gao, G.-Y.; Chen, Z.; Bao, Z.; Jin, X.; et al. BiFeO₃-Based Flexible Ferroelectric Memristors for Neuromorphic Pattern Recognition. ACS Appl. Electron. Mater. 2020, 2, 1081–1089. [CrossRef]